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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811  
Examiner: Quang D. Vu

In re PATENT APPLICATION of

Applicant : Kazutaka SHIBATA )

Appln. No. : 10/608,016 )

Filed : June 30, 2003 )

For : SEMICONDUCTOR DEVICE AND )  
MANUFACTURING METHOD THEREOF )

Atty. Dkt. : AI 288 )

AMENDMENT AFTER  
FINAL ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

OK to enter  
Imm 6/10/2006

In further response to the Final Examiner's Action mailed February 27, 2006, please  
amend the above-identified application as follows:

FEE ENCLOSED: \$  
Please charge any further  
fee to our Deposit Account  
No. 18-0002



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811

Examiner: Junghwa M. IM

In Re PATENT APPLICATION Of:

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Docket No.: AI 288

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) **AMENDMENT**  
) **AFTER**  
) **FINAL ACTION**  
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October 22, 2007

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

ok to enter

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10/31/2007

This amendment is filed in response to the Examiner's Final Action mailed on July 25, 2007. Please amend the above-identified application as follows: